



Docket No.: H6808.0024/P024  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Hiroshi Miyai et al.

Application No.: 10/669,253

Art Unit: 2881

Filed: September 25, 2003

Examiner: Bernard E. Souw

For: AN INSPECTION METHOD AND  
APPARATUS USING AN ELECTRON  
BEAM

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated August 24, 2004 (Paper No. 0816),  
please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins  
on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.